

10/516455

DT09 Rec'd PCT/PTO 03 DEC 2004

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

PCT/FR2003/002157

Docket No: Q84452

Michel PUECH

Appln. No.: Not Assigned

Confirmation No.: Not Assigned

Group Art Unit: Not Assigned

Filed: December 3, 2004

Examiner: Not Assigned

For: A METHOD AND APPARATUS FOR ETCHING A SUBSTRATE WITH A
VERY HIGH POWER INDUCTIVELY-COUPLED PLASMA

PRELIMINARY AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the
accompanying pages.

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